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CONFIRMATION NO. 5212

<b>SERIAL NUMBER</b> 10/520,982	<b>FILING OR 371(c) DATE</b> 03/14/2005 <b>RULE</b>	<b>CLASS</b> 250	<b>GROUP ART UNIT</b> 2881	<b>ATTORNEY DOCKET NO.</b> S004-5433(PCT)
<b>APPLICANTS</b> Toshio Kodama, Chiba-shi, JAPAN; Masakatsu Hasuda, Chiba-shi, JAPAN; Toshiaki Fujii, Chiba-shi, JAPAN; Kouji Iwasaki, Chiba-shi, JAPAN; Yasuhiko Sugiyama, Chiba-shi, JAPAN; Yasuyuki Takagi, Chiba-shi, JAPAN;				
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP03/08691 07/09/2003 <i>JB</i>				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2002-204028 07/12/2002 <i>JB</i>				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>Jack Berner</i> <i>JB</i> Examiner's Signature Initials		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 10	<b>TOTAL CLAIMS</b> 20
				<b>INDEPENDENT CLAIMS</b> 3
<b>ADDRESS</b> 40627				
<b>TITLE</b> Ion beam device and ion beam processing method, and holder member				
<b>FILING FEE RECEIVED</b> 1030	<b>FEES:</b> Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	